

UNITED STATES PATENT AND TRADEMARK OFFICE  
**CERTIFICATE OF CORRECTION**

PATENT NO. : 7,013,701 B2  
APPLICATION NO. : 10/730884  
DATED : March 21, 2006  
INVENTOR(S) : Kawashima

Page 1 of 2

It is certified that error appears in the above-identified patent and that said Letters Patent is hereby corrected as shown below:

On the Title Page;

**“(55) INSPECTION METHOD OF MULTILAYER  
GAS SENSING DEVICE”**

should be

**--(55) INSPECTION METHOD FOR MULTILAYER  
GAS SENSING DEVICE--.**

In Columns 11 – 12, claims 1 and 2 should be as follows:

1. A method of inspecting a multilayer gas sensing device which comprises a sensor cell including a solid electrolyte plate, a measured gas side electrode placed on a surface of said solid electrolyte plate to be exposed to a measured gas and a reference electrode placed on a surface of said solid electrolyte plate to be exposed to a reference gas, with said measured gas side electrode being coated with a porous diffusion resistance layer in a stacked condition and said diffusion resistance layer being further coated with a dense protective layer in a stacked condition, said method comprising the steps of:

    immersing said multilayer gas sensing device in a conductive inspection solution;

    placing said reference electrode into non-contact condition with said conductive inspection solution;

    applying a voltage between said conductive inspection solution and said reference electrode to measure a current flowing between said conductive inspection solution and said reference electrode; and

    making a decision as to whether or not insulation is kept between said conductive inspection solution and said reference electrode.

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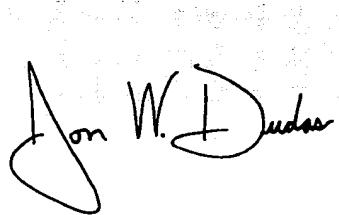
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It is certified that error appears in the above-identified patent and that said Letters Patent is hereby corrected as shown below:

2. The method according to claim 1, wherein, for applying said voltage between said conductive inspection solution and said reference electrode, said voltage is applied between a reference side external terminal, which is electrically connected to said reference electrode and formed in an exposed state in the exterior of said multilayer gas sensing device and which does not come into contact with said conductive inspection solution, and said conductive inspection solution.

Signed and Sealed this

Twenty-ninth Day of August, 2006



JON W. DUDAS  
*Director of the United States Patent and Trademark Office*